



42390.P8276

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Anne E. Miller et al.

U.S. Serial No: 09/715,282

Filed: November 16, 2000

For: SLURRY AND METHOD FOR
CHEMICAL MECHANICAL
POLISHING OF COPPER

Mail Stop Non-Fee Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Confirmation No.: 6590

Examiner: Chen, Kin Chan

Art Unit: 1765

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AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed June 12, 2003, Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on September 12, 2003

Date of Deposit

Claire Walters

Name of Person Mailing Correspondence

Claire Walters
Signature

Date

9/12/2003